

***Amendments to the Specification***

Please replace paragraph [0017] with the following amended paragraph:

**[0017]** The glass substrate 4 is slid by the robot arm 8 and safely placed on the surface of the susceptor 10. At this moment, the susceptor 10 applies heat ~~heats~~ to the glass substrate 4. ~~and Further, the susceptor 10 is used as a~~  
~~lower electrode for generating plasma.~~

**[0022]** When the glass substrate 4 is slid into the slide part 41 of the susceptor 10, it is caught by the film-forming material 11 to cause a slide to miss occur. Thereby, there occurs a problem whereby the glass substrate 4 is broken. ~~The possibility of this occurrence increases because a bend of the substrate becomes severe due to the enlargement of the substrate The larger the substrate is, the more severe the bending of substrate is, and so the possibility of a substrate being broken increases.~~

**[0042]** ~~Also, because the glass substrate 34 is placed on the surface of the susceptor 30 with an angle of 85 degree for being safely placed, the glass substrate 34 is safely placed on the susceptor 30 inclined to one side. As a result, the friction between the surface of the susceptor 30 and the glass substrate 34 changes causing the film-forming material to collect at the slide part 42 of the susceptor 30 Also, the glass substrate 34 is safely placed on the~~

susceptor 30 inclined at 85 degrees to one side. As a result, because of the friction between the surface of the susceptor 30 and the glass substrate 34, the film-forming material is collected at the slide part 42 of the susceptor 30.